

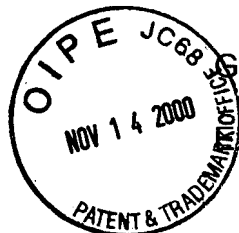
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Ki-sang KIM et al.

Serial No.: 09/237,229

Filed: January 26, 1999



Group Art Unit: 1763

Examiner: S. MacArthur

#100  
11/16/00  
MW

For: MULTI-CHAMBER SYSTEM HAVING COMPACT INSTALLATION SET-UP FOR  
AN ETCHING FACILITY FOR SEMICONDUCTOR DEVICE MANUFACTURING

AMENDMENT

Honorable Assistant Commission of Patents and Trademarks,  
Washington, D.C. 20231

Date: November 14, 2000

Sir:

In response to the Office Action dated August 14, 2000, the following  
amendments and remarks are respectfully submitted.

RECEIVED  
NOV 15 2000  
1700 MAIL ROOM

In the Claims:

Please cancel claims 33-68 without prejudice or disclaimer of the subject matter  
contained therein.

REMARKS

Claims 1-32 are pending in the present application. Claims 33-68 have been  
canceled as being directed to a constructively non-elected invention. Applicants  
respectfully reserve the right to file a Divisional Application including non-elected claims